

# **INFORMATION DISCLOSURE CITATION**

(Use several sheets if necessary)

Docket number (Optional)

15689.73

Application Number

09/889,000

Applicant(s)

Shinji Uebayashi et al.

Filing Date

June 22, 2001

Group Art Unit

2616

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

## U.S. PATENT APPLICATION PUBLICATIONS

EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

## FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
TP	1	JP 07-212817	08/11/1995	Japan	H04Q7	22	X	

EXAMINER /Tri Phan/

DATE CONSIDERED 07/27/2006

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Initial****OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)****TP****2****Official Notice of Rejection; Case No.: DCMH120076; Patent Application No.: 2000-190173****EXAMINER** /Tri Phan/**DATE CONSIDERED** 07/27/2006**EXAMINER:** Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.